

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)
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 Tetsuro Inui et al.)
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Serial No.: 10/624,082) Art Unit
) 2613
Filing Date: July 21, 2003)
)
Confirmation No.: 5995)
)
For: DISPERSION MONITORING METHOD AND)
 APPARATUS AND DISPERSION SLOPE)
 TEMPERATURE DEPENDENCY COMPENSATION)
 METHOD AND APPARATUS)
)
Examiner: Hibret Asnake Woldekidan)

AMENDMENT "D" AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Examiner:

Applicant submits this paper in response to the Office Action mailed July 23, 2009.
Reconsideration is respectfully requested in view of the following remarks:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 8 of this paper.